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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2891
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79277

Kazuyuki KUWADA, et al.

Appln. No.: 10/752,700

Group Art Unit: 2891

Confirmation No.: 5921

Examiner: Dana Farahani

Filed: January 08, 2004

For: SEMICONDUCTOR DEVICE AND PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE

RESPONSE UNDER 37 C.F.R. § 1.116

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 5, 2006, please consider the remarks as submitted herewith on the accompanying pages.

REMARKS

Claims 1-7 are all the claims pending in the application. Claims 1 and 6-7 are before the Examiner for examination and claims 2-5 are withdrawn as being drawn to a non-elected invention.

I. Request for Acknowledgement of Receipt of Priority Document

Applicants claim foreign priority to JP 2003-005551 filed in Japan on January 14, 2003. A certified copy of the priority document was filed with the present application on January 8,